

Highly-dispersive mirrors reach new levels of dispersion

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Abstract: A highly-dispersive mirror with the unprecedented group delay dispersion of -10000 fs^2 in the wavelength range of 1025–1035 nm is reported. Reproducible production of a coating with such a high dispersion was possible due to the recently developed robust synthesis technique. Successful employment of the new highly-dispersive mirror in an oscillator is demonstrated.

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OCIS codes: (310.4165) Multilayer design; (310.1620) Interference coatings; (320.5520) Pulse compression.

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1. Introduction

Highly-dispersive mirrors (HDMs) have become a key tool in the field of ultrafast physics over the last two decades [1–4]. Presently, the majority of femtosecond lasers include dispersive mirror optics which allow precise control of group delay dispersion (GDD) characteristics.

Due to its power scalability, thin-disk (TD) technology may constitute the basis for next-generation femtosecond laser oscillators, yielding average output powers exceeding 140 W [5,6] and pulse energies of 40 μJ [6], with pulse durations of 700–1000 fs.

More recently, a power scalable laser setup, where an Yb:YAG TD oscillator delivered an average output power of 270 W, corresponding to 14.4 μJ pulse energy at 18.8 MHz repetition rate in the mode-locked regime, has been presented [7]. Mode-locked operation in the regime of anomalous dispersion was realized by 8 bounces each on two HD folding mirrors with a GDD of -3000 fs^2 each [4], introducing a total roundtrip GDD of -48000 fs^2 .

Scaling passively-mode-locked femtosecond laser oscillators to ever higher pulse energies calls for ever higher negative GDD in the cavity. Meeting this requirement with an increasing number of bounces off dispersive mirrors tends to increase alignment sensitivity, round-trip losses, and complexity of the system. Advancing femtosecond oscillator technology to higher peak as well as average powers relies on the development of HDMs with higher levels of dispersion.

Generally, the larger the required bandwidth, the smaller the achievable mean value of GDD in dispersive mirrors [2,4]. Recent studies [8] have shown that there are certain limitations for the maximum achievable negative value of GDD, which depend on the total thickness of coatings and the layer material combination. For multilayer structures based on the material pair $\text{Ta}_2\text{O}_5/\text{SiO}_2$ this value reaches -7000 fs^2 for a thickness of 9.8 μm . Today, state-of-the-art coating technology allows to produce coatings with total physical thicknesses larger than 10 μm and to reach even higher levels of GDD. Here we report achievement of the maximum possible negative GDD allowed by this total design thickness and its successful application in an Yb:YAG TD oscillator.

2. Design considerations

A commercial OptiLayer software package [9] was used to design an HDM with high negative dispersion. The software utilizes most powerful approaches such as needle optimization and gradual evolution algorithms [10–12], enabling one to avoid problems of convergence at a local minimum.

An implementation of a single HDM with a GDD of -10000 fs^2 is a challenge due to the high sensitivity of the design performance to manufacturing errors. In view of this fact additional considerations had to be made. A method to circumvent manufacturing errors is presented in [13], which can be considered as a generalization of the highly efficient needle optimization and gradual evolution techniques [10–12]. The described robust synthesis procedure was used in this work.

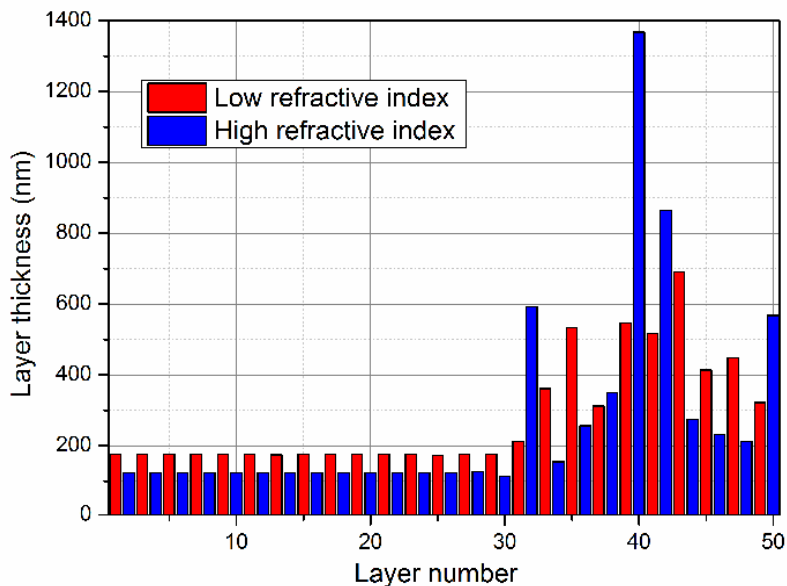


Fig. 1. Physical thicknesses of the individual layers of the HDM. Red bars represent the low refractive index material SiO₂. Blue bars represent the high index material Ta₂O₅. The layers are displayed starting from a substrate. The bottom layer #1 is closest to the substrate, the top layer #50 is closest to the incident medium (air).

The target design was optimized to have a GDD of -10000 fs^2 and reflectance of 100% for the wavelength range 1025–1035 nm. According to [8], where the limits for the maximum achievable negative value of the GDD have been studied, the target GDD of -10000 fs^2 is achievable for the specified spectral range and for the chosen thin film materials with state-of-the-art deposition technology. The layer thicknesses of the optimized multilayer structure are shown in Fig. 1. Dependencies of the refractive indices on the wavelength are described by the Cauchy formula:

$$n(\lambda) = n_{\infty} + A / \lambda^2 + B / \lambda^4 \quad (1)$$

where λ is the wavelength expressed in microns, n_{∞} , A and B are coefficients presented in Table 1.

Table 1. Cauchy formula coefficients for the substrate and layer materials.

| | n_{∞} | A | B |
|--------------------------------|--------------|-----------|------------|
| Suprasil | 1.4433 | 4.06E-3 | 6.94818E-6 |
| SiO ₂ | 1.4653 | 0.0 | 4.71080E-4 |
| Ta ₂ O ₅ | 2.0657 | 1.6830E-2 | 1.686E-3 |

The obtained via the described above robust procedure design consists of 15 pairs of alternating quarter-wave layers (corresponding to the central wavelength of 1030 nm) of Ta₂O₅ and SiO₂, the material pair which is usually used for low loss coatings with relatively small bandwidths (200–300 nm), and 20 chirped top layers, resulting in 50 layers and a total thickness of 13.7 μm .

3. Production process

The designed multilayer structure was produced by use of the magnetron sputtering technique (Helios, Leybold Optics) equipped with broadband in situ monitoring (BBM) [14]. The plant

is equipped with two proprietary TwinMags magnetrons and a plasma source for plasma/ion-assisted reactive middle-frequency dual-magnetron sputtering. It exploits precise time-controlled monitoring of layer thicknesses, based on careful calibration of deposition process parameters affecting deposition rates, with additional control provided by the BBM system. A Suprasil substrate was used as a test witness sample during the process. Layers at deposition rates of 0.4 nm/s allow for rapid manufacturing as well as the production of dense layers (near intrinsic solid density) with excellent homogeneity and high reproducibility.

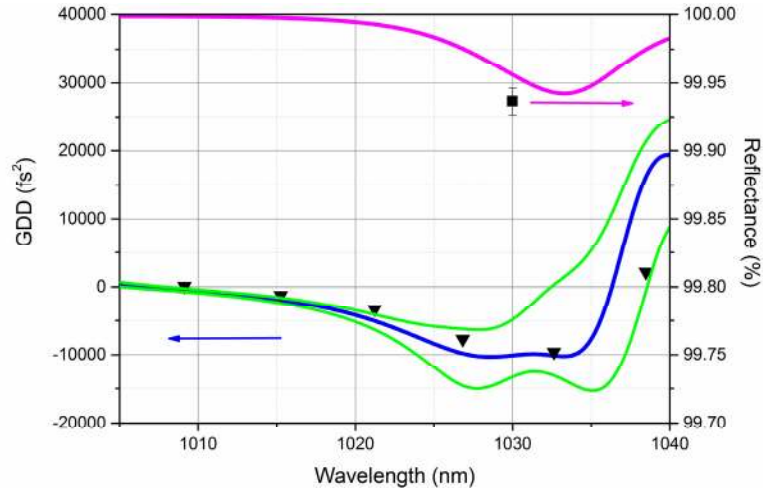


Fig. 2. Comparison of the designed and measured data for the new HDM: The designed GDD for 3° angle of incidence (blue curve), error bars ± 0.5 nm (green curves); the measurement performed with a WLI at 3° angle of incidence (black triangles). The designed reflectance for 7.5° angle of incidence (magenta curve), the square at 1030 nm represents the measurement performed with a lossmeter at 7.5° angle of incidence.

The produced samples were characterized with the help of a home-built white-light interferometer (WLI) [15–18] and a lossmeter based on a cavity ring-down technique (NovaWave Technologies LossPro). The comparison of the designed and measured data is presented in Fig. 2, revealing a good agreement between theory and experiment. Most importantly, the agreement is particularly good in the relevant (1025–1035 nm) wavelength range. The result proves the feasibility of robust HDMs with negative GDD relying on physical thicknesses in excess of 10 μm .

The main benefit of the HDM developed in the present study is the possibility to obtain high negative GDD in a single optical element. The HDM reported here operates perfectly in a laser system and exhibits total losses of 600 ppm. HDMs having a GDD of -4000 fs^2 with total losses of 1000 ppm and a GDD of -3000 fs^2 with total losses of 300 ppm were demonstrated in [4]. The HDM reported here possesses over twice the GDD without the expense of introducing further losses.

4. HDM in Yb:YAG oscillator

Here we report the first application of the newly-created HDM, as a source of GDD required to implement stable Kerr-lens mode-locking (KLM) in an Yb:YAG TD laser. In order to test the new HDM 4 standard DMs from [2] (3 bounces on -3000 fs^2 mirrors and 1 bounce on -1000 fs^2 mirror in reference setup) were replaced by 3 highly-reflective (HR) mirrors and the new HDM (test setup), providing the same amount of GDD, namely -20000 fs^2 per roundtrip.

The oscillator used was a basic diode-pumped Yb:YAG TD oscillator in which mode-locking was achieved by hard-aperture KLM with a 2-mm sapphire crystal serving as the nonlinear Kerr medium (Fig. 3). The oscillator was operated in the mode-locked regime at a repetition rate of 33.7 MHz with an average output power of approximately 4 W.

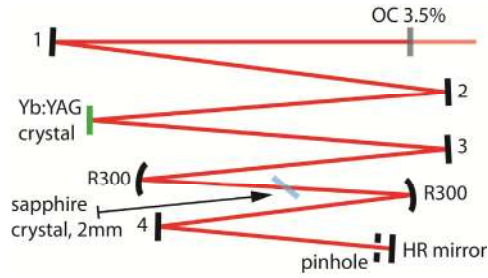


Fig. 3. Schematic of the oscillator built for testing the intra cavity behavior of the new HDM. The oscillator is a basic diode-pumped KLM Yb:YAG TD laser. OC, output coupler. R300, HR mirrors with radius of curvature 300 mm. Mode-locking was achieved by hard aperture KLM with the sapphire crystal and a pinhole. Mirrors 1 to 4 were either a set of 4 known DMs with a total roundtrip GDD of -20000 fs^2 or 3 HR mirrors and the new HDM with the same amount of GDD. During the measurements the oscillator ran at 33.7 MHz repetition rate with an output power of $\sim 4 \text{ W}$.

The spectrum and the autocorrelation of the pulses were measured for both setups. Figure 4 provides evidence that the measured curves fit the expected sech^2 -function well. The spectra are centered around a wavelength of 1030.5 nm with a full-width at half-maximum (FWHM) of 4.2 nm in the reference case and 3.9 nm in the test case. Pulse durations of 290 fs and 320 fs in the reference and test setup respectively were calculated from their autocorrelation via $\tau_p = \tau_{ac} / 1.543$ [19], where τ_p is the FWHM of the pulse intensity and τ_{ac} is the FWHM of the intensity autocorrelation. Since realignment of the cavity between the two experiments is unavoidable it cannot be concluded that the slight difference in spectral width and pulse duration is solely attributed to the new HDM.

The advantage of having only one mirror providing the GDD is that fewer mirrors can be used to build a working cavity. This improves the stability and simplifies the alignment since fewer degrees of freedom need to be taken into account and fewer surfaces are prone to optical damage. The use of fewer mirrors also establishes the possibility to build shorter cavities with higher repetition rates.

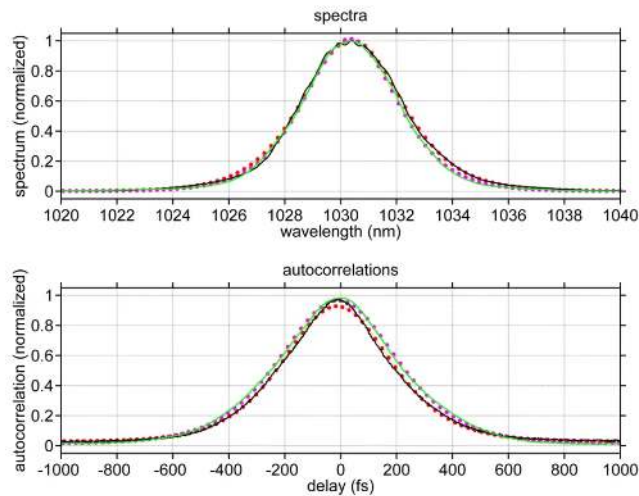


Fig. 4. Comparison of spectra (top) and autocorrelations (bottom) of a basic KLM Yb:YAG oscillator working with the known mirror set and with the new HDM. In both graphs the color coding is as follows: measured data with reference setup (black line), measured data with test setup (green line), fitted sech^2 -function to reference data (red dots), fitted sech^2 -function to test data (magenta dots).

It is important to mention that the rather large thickness of the produced coating may lead to a reduction in the damage threshold or to thermal effects, such as expansion and deformation of the coating at higher intra cavity powers. HDMs with a GDD of -10000 fs^2 possessing higher damage thresholds and negligible thermal effects are in the process of development.

5. Conclusion

A single HDM with a GDD reaching the value of -10000 fs^2 in the wavelength range 1025–1035 nm has been presented for the first time. The recently reported robust technique has been used in order to circumvent manufacturing errors and to produce a challenging, rather thick ($13.7 \mu\text{m}$) coating with such a large negative GDD for central wavelength of 1030 nm. The produced HDM was successfully utilized in an Yb:YAG TD oscillator, operating at 33.7 MHz repetition rate with an output power of about 4 W, which resulted in a pulse duration of 320 fs.

Advancing HDMs to ever higher negative dispersion benefits the development of compact, user-friendly, high-power femtosecond oscillators and may even open the prospect for simplifying pulse stretching-compression schemes in chirped-pulse amplifier systems.

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